Product Change Notification (Notification - P1508028) (MC3-J-15-003) August 21, 2015										
То:	Our Valued Customer (Insert Customer Name Here)									
Overview:	The purpose of this notification is to communicate product change of select Renesas Electronics America, Inc. (REA) devices. There is no change to the part number.									
	This notification announces the addition of a wafer fabrication site for RL78 microcontrollers. In addition to the current wafer fabrication site (Kawashiri), a new site (Saijo) will begin manufacture of RL78 devices.									
Affected Products:	A review of our shipment records to your company indicate the attached list of products is affected by this notification.									
	Booking Part Number	PCN Note								
	Insert PN1 here	Vafer Eabrication Site								
	Insert PN2 here		Wafer Fabrication Site							
	Insert PN3 here	Addition of Saijo as a Wafer Fabrication Site Addition of Saijo as a Wafer Fabrication Site								
	Insert PN4 here Addition of Saijo as a Water Fabrication Site									
	Part numbers given in this list are for active part numbers in REA database at the time of this notification.									
Key Dates:	Cross shipments from REA of products from the additional wafer fabrication site begin.									
Response:	No response is required. REA will consider this notification approved 30 days after its issue. If you anticipate volumes beyond your regular rate prior to the transition date, please contact your REA sales representative with a forecast of your requirements.									
Please contact your REA	A sales representative for any questions of	or comments.								
Thank you for your atten	tion.									
Sincerely,										
Renesas Electronics Am	ierica, Inc.									

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Booking Part	REA	Notificat		Replace ment	EOL	Type of Announ	cnt	Notificati	LTB LTS	Transition	PCN Note for Customers	тм
Number	Action	ion Type	Group	PN	Period	cement	ent	on #		Date		
	DCN	DCN 1D	MCU				1	D1500000		11 15 2010	Addition of California Mafer Fabrication Cita	. .
R5F10RB8AFP#V0 R5F10RB8AFP#X0	PCN PCN	PCN-1B PCN-1B	MCU MCU			PCN PCN		P1508028 P1508028		11-15-2016 11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RBAAFP#X0	PCN		MCU			PCN		P1508028			Addition of Saijo as a Wafer Fabrication Site	Vu Vu
	PCN	PCN-1B	MCU							11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RBAAFP#X0		PCN-1B PCN-1B	MCU			PCN PCN		P1508028 P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	
R5F10RBCAFP#V0 R5F10RF8AFP#V0	PCN PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016 11-15-2016	Addition of Saijo as a Wafer Fabrication Site Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RF8AFP#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RFAAFP#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RFCAFP#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RG8AFB#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Water Fabrication Site	Vu Vu
R5F10RG8AFB#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Water Fabrication Site	Vu Vu
R5F10RGAAFB#V0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RGAAFB#X0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RGCAFB#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu Vu
R5F10RGCAFB#X0	PCN	PCN-1B PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Water Fabrication Site	Vu Vu
R5F10RGCGFB#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10RJ8AFA#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10RJ8AFA#X0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10RJAAFA#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10RJCAFA#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10RLAAFB#V0	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WLCAFB#30	PCN	PCN-1B	MCU			PCN		P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10WLCAFB#50	PCN	PCN-1B	MCU			PCN	1	P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WLCGFB#50	PCN	PCN-1B	MCU			PCN	1	P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WLEAFA#30	PCN	PCN-1B	MCU			PCN	1	P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WLEGFB#30	PCN	PCN-1B	MCU			PCN	1	P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WMCGFB#30	PCN	PCN-1B	MCU			PCN	1	P1508028		11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu

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R5F10WMEAFA#30	PCN	PCN-1B	MCU	PCN	1	P1508028	11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WMEAFB#50	PCN	PCN-1B	MCU	PCN	1	P1508028	11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
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R5F10WMGAFB#50	PCN	PCN-1B	MCU	PCN	1	P1508028	11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu
R5F10WMGGFB#30	PCN	PCN-1B	MCU	PCN	1	P1508028	11-15-2016	Addition of Saijo as a Wafer Fabrication Site	Vu